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50. A device manufacturing method, characterized by producing a device through manufacturing processes including a process for exposing a substrate by use of an exposure apparatus as recited in Claim 47.

51. A device manufacturing method, characterized by producing a device through manufacturing processes including a process for exposing a substrate by use of an exposure apparatus as recited in Claim 48.

52. A device manufacturing method, characterized by producing a device through manufacturing processes including a process for exposing a substrate by use of an exposure apparatus as recited in Claim 49.--

REMARKS

Applicants request favorable consideration of the above-referenced application in view of the foregoing amendments. Claims 1-52 are pending. Claims 43 and 44 have been amended, and claims 46-52 are newly presented to avoid any improper multiple dependencies.

Applicants' undersigned attorney may be reached in our Washington office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



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